

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No. 3619

Tadashi MAEGAWA, et. al.

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Examiner: Sylvia MacARTHUR

For: SUBSTRATE PROCESSING APPARATUS

VIA EFS WEB
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art cited in a communication from a foreign patent office in a counterpart foreign application, together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in connection with a corresponding patent application, to the best of applicant's knowledge, not more than three months prior to the filing of this Submission. A translation of the relevant parts of the foreign Office Action has been provided in lieu of a Statement of Relevancy of the present invention to the teachings of the cited prior art.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

Respectfully submitted,

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